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41,733 Reg. No.

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Applicant

Alain Izadnegahdar et al.

Serial No.

09/90**6**,847

Filed

July 20, 2001

Title

THIN PIEZO RESISTIVE PRESSURE SENSOR

Docket No.

015559-250

Art Unit

2855

Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Pursuant to 37 C.F.R. §1.56, the Examiner's attention is directed to the references listed on the attached Information Disclosure Citation, copies of which are attached.

It is to be understood that the present submission of art is in no way intended to be a waiver of any arguments or defenses available to the applicant under the rules of the U.S. Patent and Trademark Office and the statutes of the United States.

No fee is required. The Commissioner is authorized to charge any additional fees required by this paper or to credit any overpayment to Deposit Account No. 20-0809.

Respectfully submitted:

By:

Steven J. Elleman

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INFORMATION DISCLOSURE OF TAXION Page 1 of 2 Pages

Docket:	015559-250		Serial. No.:	09/909,847	
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Applicant: Alain Izadnegahdar et al.

Filed: 7/20/01 Group: 2855

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^{*} Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION Docket: 015559-250 Serial. No.: 09/909,847 Page 2 of 2 Pages Applicant: Alain Izadnegahdar et al. Filed: 7/20/01 Group: 2855 **U.S. PATENT DOCUMENTS** Document No. Examiner Date Name Class Sub 6,084,257 07/00 Petersen et al. 6,106,476 08/00 Corl et al. 6,140,143 10/00 Christel et al. 6,167,763 01/01 Tenerz et al. FOREIGN PATENT DOCUMENT Trans Examiner Document No. Date Country Class Sub Y N OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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Papers: Information Disclosure Statement (1 pg); Information Dog

Disclosure Citation (2 pg); and 15 cited references

Inventor(s): Izadnegahdar et al. Title: THIN PIEZO RESISTIVE PRESSURE SENTON PE

Serial No.: 09/909,847 Docket No.: 015559-250 Due Date: 12/20/01

Client Name: Goodrich Corporation

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